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INVESTIGATIONS IN THE VACUUM ULTRAVIOLET OF A STEADY STATE NITROGEN PLASMA

by

James Carlin Beam



United States Naval Postgraduate School



THESIS

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James Carlin Beam Lieutenant Commander, United States Navy B.S., Naval Academy, 1960

Submitted in partial fulfillment for the requirements for the degree of

MASTER OF SCIENCE IN PHYSICS

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rk was partially supported by Naval Ordnance Laboratory, Oak, under order number P.C. 7-0034.



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ABSTRACT

In preparation for studies of shock waves in a collisionless plasma, a grazing incidence vacuum spectrograph has been used to study the vacuum ultraviolet spectra of a nitrogen plasma. The spectra are formed by a concave grating with a l-meter radius of curvature and recorded on Kodak SWR (Shortwave-Radiation) Film. Analysis of the spectra was by comparison with helium and argon spectra, with intensity information from densitometric measurement using a Leeds and Northrup recording densitometer. Relative intensity determination provides an electron temperature evaluation technique.

Details on the modification of the Naval Postgraduate School plasma facility to accommodate a theta-pinch shock generation experiment are presented. Revised operating procedures for the new system configuration are included in the appendix.

A total of 735 lines was observed in the range 300-2000 angstroms. Relative intensity measurements indicated electron temperatures in the range 7.3 to 19.7 electron volts. Predicted relative intensities using a variable combination of the Local Thermal Equilibrium and Corona plasma models showed good sensitivity to temperature, but little difference between models.

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I. BACKGROUND AND THEORY

A. INTRODUCTION

Modification of the Naval Postgraduate School reflex arc plasma facility to accommodate a shock wave generation experiment has been completed. The disturbance in the plasma column is accomplished by a short period capacitor discharge through a single coil mounted co-axially with the plasma vacuum tube. Investigation of the shock wave generation, velocity, and attenuation in a nitrogen plasma is presently being conducted. Background investigations of the visible and ultraviolet radiation emitted by the steady state plasma were necessary prior to the investigation of shock front emissions. The object of this investigation was to provide a spectral survey of the nitrogen plasma in the vacuum ultraviolet region under varying conditions of longitudinal magnitude field strength and at different locations along the ten foot plasma column. Some work was also completed in evaluating electron temperatures from observed spectral line relative intensities.

The entire shock disturbance program was undertaken in an attempt to solve investigative problems in studies of shock waves in low pressure atmospheric gases. Previous experimentation has been hampered by impurity problems and by atmospheric absorption of emitted radiation. The solution to these problems could best be accomplished through study of a magnetically confined laboratory plasma. Use of vacuum ultraviolet detectors is of considerable importance in radiation studies of multiple-ionized gases, since the most intense emission lines occur in the vacuum ultraviolet.

This report describes the vacuum ultraviolet investigation of the nitrogen plasma, modification of the plasma system for shock wave studies, and presents identifications of the observed spectra. Additionally, two computer programs are presented for use in spectral analysis. One is a more sophisticated version of previous work in electron temperature evaluation from relative line intensities based on either local thermal equilibrium or corona conditions. The second generates predicted relative intensities for fixed electron temperatures based on various combinations of LTE and corona radiation models.

Past work in the steady state nitrogen plasma includes probe measurements of electron temperatures [1], a spectral survey of the visible nitrogen spectrum, and preliminary intensity analysis using a dual beam spectrophotometer [2]. Investigations continue in both areas. Previous vacuum ultraviolet investigation was limited to argon and helium plasmas [3].

B. GRAZING INCIDENCE ULTRAVIOLET SPECTROSCOPY

Investigations in the region above 1000 A may be made with conventional mountings of diffraction gratings at normal incidence. Reflectance of concave gratings, although of low magnitude in the range 1000 Å to 2000 Å, is acceptable provided a suitable vacuum-deposited reflecting film is used. The material most generally used is platinum, which for normal incidence has a reflectance of 22% for radiation as short as 600 Å [4]. For investigations of wavelengths below 600 Å one must resort to grazing incidence spectroscopy. As suggested by past research in the vacuum ultraviolet, a one-meter radius of curvature concave grating has been platinum coated for use

at grazing incidence. There are no suitable transmittance optics in this region. Even the number of reflections must be kept to an absolute minimum. For these reasons, the vacuum ultraviolet spectrograph was designed to utilize a Rowland mounted concave grating at grazing incidence.

The spectrograph optics are shown schematically in Fig. 1. Angle of incidence is set at 82°. The theory of operation of the concave grating has been discussed in detail by Beutler [5] and others. The fact that Rowland conditions are valid at grazing incidence allows rather simple evaluation of the reciprocal dispersion as:

$$\frac{d\lambda}{d\ell} = \frac{d}{m R} \cos \psi$$

where ℓ is the distance from the central image to the position of a spectral line of wavelength λ (as measured along the Rowland circle), d/m is the groove spacing of the grating, and ψ is the angle of diffraction. The reciprocal dispersion of the grating used is summarized below.

Ψ	d\/dl
00	16.7 A/mm
45 ⁰	11.8
75 ⁰	4.32
80°	2.90
81°	2.61
82°	2.33
83 ^O	2.04

Note from the equation that d^{ℓ}/d^{λ} is directly proportional to $1/\cos \psi$. Thus as ψ approaches 90° , d^{ℓ}/d^{λ} becomes infinite.

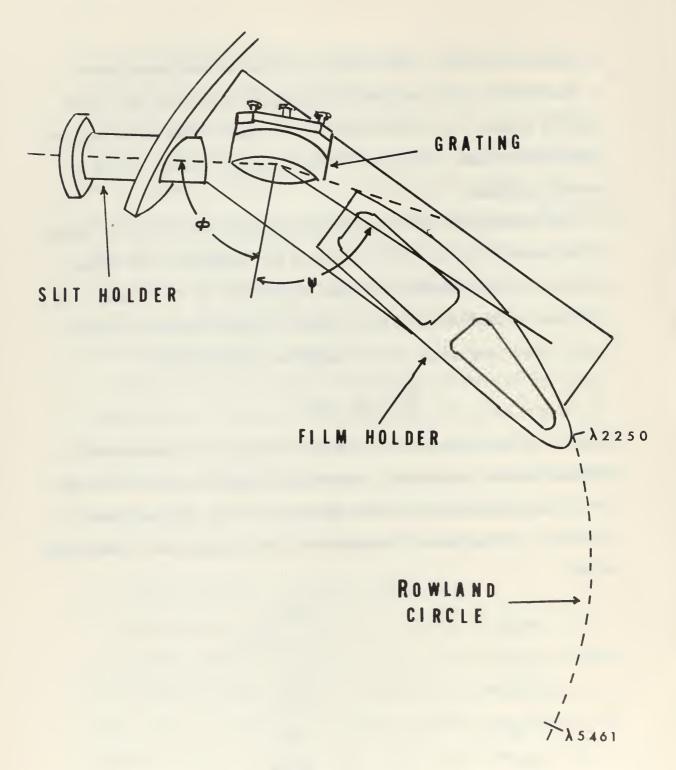


FIG. 1

GRAZING INCIDENCE
SPECTROGRAPH OPTICS

The advantage of higher angular dispersion at grazing incidence is obvious. Resolving power, on the other hand, decreases at grazing incidence. As shown by Samson [6], resolving power is directly proportional to the optimum width of the grazing which decreases from 21.6 cm at normal incidence to 2.2 cm at 80° incidence for a wavelength of 500° Å.

C. NITROGEN PLASMA

Previous studies have described the steady state reflex arc. Ionization has been estimated at 95%. Electron temperatures on the order of 4.0 eV have been reported by Orlicki [7], et al, although a computer program error affected the results slightly. Present work with Langmuir probes and a dual beam spectrophotometer indicates values of electron temperatures in the range 3.5 to 8.0 eV. Previous estimates of ion temperatures are 5×10^3 oK maximum, and electron densities approximately $2 \times 10^{18}/\text{m}^3$. The ion temperature was estimated from previous unpublished work on interferometer measurement of Doppler broadening. Null results make the assumed value an upper limit of the ion temperature.

Of particular importance in considering possible diagnostics for shock wave investigation are the characteristic collision times. Relative line intensity analysis is dependent on the assumed radiation model. Determination of the time required for a perturbed plasma to restore itself to the condition of local thermal equilibrium is necessary to establish the validity of using an LTE based intensity analysis. Based on electron—ion collision time equations developed by Spitzer [8], and Rose and Clark [15]

$$\left. \begin{array}{c} \tau_{\theta} \text{ ee} \\ \tau_{\theta} \text{ ii} \end{array} \right\} = \frac{25.8 \sqrt{\pi} \varepsilon_{0}^{2} \text{ m}^{1/2} \text{ (kT)}^{3/2}}{q^{4} \text{ n}_{e,i} \text{ ln}^{\Lambda}}$$

where Λ is a measure of the number of electrons in a Debye sphere and other symbols are well known. For electron-ion and ion-electron collisions the collision times are given by

$$\frac{m_{e}}{m_{i}} \tau_{\theta} i e = \tau_{\theta} e i = \frac{32 \sqrt{2\pi} \varepsilon_{o}^{2} m_{e}^{1/2} (kT_{e})^{3/2}}{(Zq^{2})^{2} n_{i} \ln \Lambda}$$

Assuming for the NPGS plasma the following parameters according to previous evaluations;

$$T_e = 5 \times 10^4 \text{ }^{\circ}\text{K}$$
 $T_i = 5 \times 10^3 \text{ }^{\circ}\text{K}$
 $n_e = n_i = 2 \times 10^{18} / \text{m}^3$
 $\ln N = 10 \text{ (as given by Spitzer)}$

we find for the collision times:

$$\tau_{\theta} = 0.148 \times 10^{-6} \text{ sec}$$
 $\tau_{\theta} = 0.754 \times 10^{-6} \text{ sec}$ (N⁺)
 $\tau_{\theta} = 260.8 \times 10^{-6} \text{ sec}$
 $\tau_{\theta} = 6.7 \text{ sec}$ (N⁺)

Since scattering of ions by electrons is much slower than relaxation through ion-ion collisions, it is expected that any effects of a disturbance which selectively heats ions may be observed as increased ion temperature and that analysis may assume equilibrium conditions.

In particular, for a shock front which raises the ion temperature to just double the electron temperature, calculations assuming the previous electron temperature give an ion-ion collision time of 67.5×10^{-6} sec for N⁺. In collisionless heating of the plasma most of the energy should be transferred to the ions, making the previous assumptions plausible. It may be concluded that shock perturbation of the ion temperature will be observable, but time resolution may be necessary.

D. LITE AND CORONA PLASMA RADIATION MODELS

Quantitative spectral analysis requires the assumption of specific equilibrium conditions in the plasma. The simplest of the radiation models is the assumption of local thermal equilibrium. LTE as defined by McWhirter [9] assumes that the distribution of electron density populations is determined by particle collision processes with immediate response to changes in plasma conditions. Electron collision processes dominate with electrons having a Maxwellian distribution.

Observation of a particular area of the plasma gives average values of electron temperature and density over the area. The plasma parameters may have time and spatial variation, but population densities for any point are uniquely determined by the local values of temperature, density, and composition. Relative number densities of like species may be expressed solely in terms of the appropriate statistical weights and Boltzmann factors; e.g.,

$$N_{n}/N_{m} = \frac{g_{n} \exp(-E_{n}/kT)}{g_{m} \exp(-E_{m}/kT)}$$

Local thermal equilibrium requires negligible radiative decay. This condition is met most closely in dense laboratory plasmas. When the

plasma electron density decreases to the point where radiative decay becomes important LTE is no longer a valid model.

Based on the probability of radiative transitions being comparable with collisional transitions under certain conditions, McWhirter has derived a validity criterion for the assumption of local thermal equilibrium. The criterion,

$$n_e \ge 1.6 \times 10^{12} T_e^{1/2} \chi(p,q)^3 cm^{-3}$$

where,

 $n_{\alpha} = \text{electron density } (\text{cm}^{-3})$

 $T_e = electron temperature (OK)$

 $\chi(p,q)$ = excitation potential of level p from level q (volts)

Using the previously stated average electron temperature of 5×10^4 $^{\circ}$ K, $\chi(p,q)=1 \text{lv}$ (for the 1200 Å transition of NI), then the electron density must be greater than 4.76×10^{17} cm $^{-3}$. Previously estimated electron densities are nowhere near this magnitude. Griem [10] has suggested that the validity criterion may be even more stringent since actual plasmas are both inhomogeneous and time dependent. On the other hand, if quantitative results from assumption of local thermal equilibrium agree with independent diagnostic methods, LTE may give acceptable results for certain ion species. The simplicity of the LTE model makes its use desirable whenever possible.

At the other extreme is the assumption that collisional ionization and excitation are balanced by radiative recombination and spontaneous decay. This model is the corona-radiative plasma model described in detail by Griem [10], McWhirter [9], and others. Population density distributions are now based on the assumption of a Maxwellian velocity distribution for free electrons as in the LTE model and balance between

collisional excitation from the ground level and spontaneous radiative decay instead of the collisional balance of LTE. This balance condition is met in cases where the electron density is too low to meet the validity criterion for LTE.

Line intensities are dependent on the relative number of electrons in an excited state, probability for the particular transition from that state to occur, and observational probability with respect to the emitted radiation. Population densities are determined by excitation and de-excitation processes in the plasma. Atomic transition probabilities prescribe the most likely route for de-excitation of an excited state. Observational probability is disregarded by assumption that the plasma is optically thin; i.e., emitted radiation is not self-absorbed by the plasma. A very general expression for spectral line intensity is then,

$$I(p,q) = 1/4\pi \int n(p) A(p,q) hv (p,q) ds$$

where n(p) is the population density of level p, v(p,q) is the frequency of the emitted photon, and A(p,q) is the atomic transition probability for the transition between bound levels p and q. A(p,q) may be evaluated quantum mechanically using various theoretical approximations (notably the Coulomb approximation and Self-Consistent Field approximation) or experimentally from the previous equation.

If intensities are to be used in plasma electron temperature analysis, the line intensity ratio technique is most generally used. This avoids the requirements for absolute intensity measurements and determination of population density distributions when the observed spectral lines are of the same species.

Assuming local thermal equilibrium, electron temperatures may be evaluated through knowledge of relative spectral line intensities by using an equation given by Robinson and Lenn [11]:

$$T_{e} = \frac{E_{m2} - E_{m1}}{k \ln \left[\frac{I_{1}}{I_{2}} \frac{g_{2}}{g_{1}} \frac{f_{2}}{f_{1}} \left(\frac{\lambda_{1}}{\lambda_{2}}\right)^{3}\right]}$$

where, E_{ml} , E_{m2} = excitation energies of the first and second levels, respectively

k = Boltzmann constant

I₁,I₂ = relative line intensities

g1,g2 = statistical weights of the upper states

 $f_1, f_2 = absorption oscillator strengths$

 λ_1, λ_2 = wavelengths of the transitions

This equation may be developed from the expression for the absolute line intensity,

$$I_{mn} = [A_{mn} (E_m - E_n) g_m N/Q] \exp (-E_m/kT_e)$$

where N is the species number density, Q is the internal partition function, and other terms are as previously defined. Again it is seen that line intensities are dependent on the population distribution of electrons in the excited state, N exp $(-E_{\rm m}/kT_{\rm e})$, and the probability of the transition $A_{\rm mn}$. Dividing the above expression by a like equation for another transition of the same atomic species, number densities and the internal partition functions are eliminated.

$$\frac{I_1}{I_2} = \frac{g_1 A_1 V_1}{g_2 A_2 V_2} \exp \left[-(E_{ml} - E_{m2})/kT_e\right]$$

Additionally, intensities need not be measured absolutely since on solving for T_e , the intensities appear as a ratio. Only the relative strengths are necessary. Using the expression for atomic transition probability in terms of the absorption oscillator strength, f_{mn} ,

$$A_{mn} = constant \times f_{mn}/\lambda^2$$

the expression given for electron temperature is reached.

The Corona model is very similar in terms of analysis to the LTE model. Balance of the collisional-excitation rate from the ground state with the spontaneous decay rate brings in a factor of $(E_{ml}/E_{m2})^3$ in the expression for the number density. This modification of the Saha-Boltzmann equations does not cancel for line ratio expressions since the excitation potentials of the two excited levels are usually not the same. Based on this departure from the Boltzmann and Saha equations for distributions of population densities, the electron temperature as given for Local Thermal Equilibrium is changed to:

$$T_{e} = \frac{E_{m2} - E_{m1}}{k \ln \left[\frac{I_{1}}{I_{2}} \frac{g_{2}}{g_{1}} \frac{f_{2}}{f_{1}} \left(\frac{E_{1}}{E_{2}} \right)^{3} \left(\frac{\lambda_{1}}{\lambda_{2}} \right)^{3} \right]}$$

where all symbols are previously defined. A computer program is given in Appendix F to derive electron temperatures for either model. The computer program given in Appendix G will generate relative line intensities from known electron temperatures and mixes of the two basic radiation models. Values for oscillator strengths and statistical weights were obtained from Griem [10] and Wiese, Smith, and Glennon [12].

II. APPARATUS

A. SPECTROGRAPH

The grazing incidence vacuum spectrograph used for the vacuum ultraviolet survey of the nitrogen plasma was designed by R. L. Kelly [13]. It has survey capability in the range 100 - 2250 Å and is compatible with the NPGS plasma reflex arc vacuum system. A schematic diagram shows the principal features of the spectrograph (Fig. 1). Mounted on the front plate of the vacuum tank is a slit assembly with entrance slit set at 15 microns. The grating mount and film holder are supported by a channel beam welded to the front plate. The vacuum enclosure consists of a 10-inch I.D. aluminum tube which bolts to the front plate. The rear of the system has a removable back plate allowing film loading.

The grating used was a Bausch and Lomb replica diffraction grating with a 998.8 mm radius of curvature, 600 grooves per mm, blaze angle of 4° 45' for a blaze wavelength of 2760 Å, used at 82° angle of incidence. This grating differed from the grating previously used in that it was platinum coated for greater reflectance in the extreme vacuum ultraviolet.

The spectrograph vacuum system consists of a 4" National Research Corporation Model 0161 diffusion pump and a Welch Scientific high vacuum Duo-Seal Model 1402 mechanical pump. In operation the combined pumping system provided, with cold trapping, a fifteen minute recycle capability from atmospheric pressure to one micron or less. The complete spectrograph system is shown in Fig. 2.

VACUUM ULTRAVIOLET SPECTROGRAPH OPERATIONAL SCHEMATIC

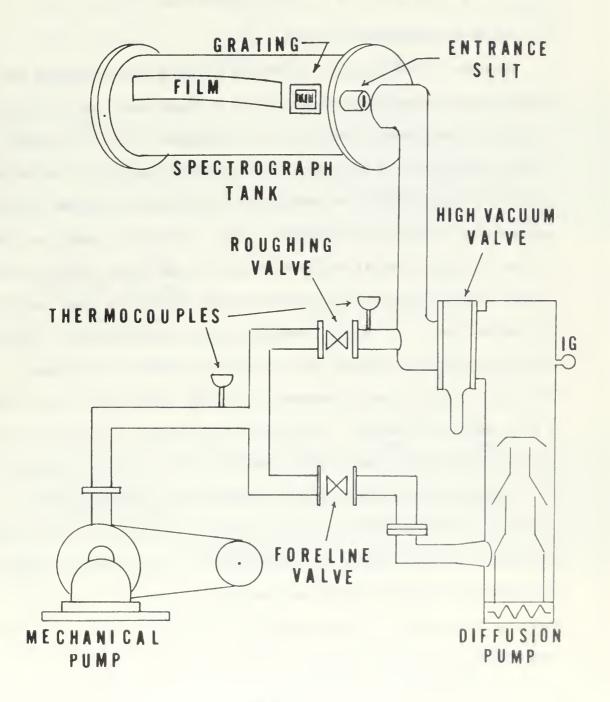
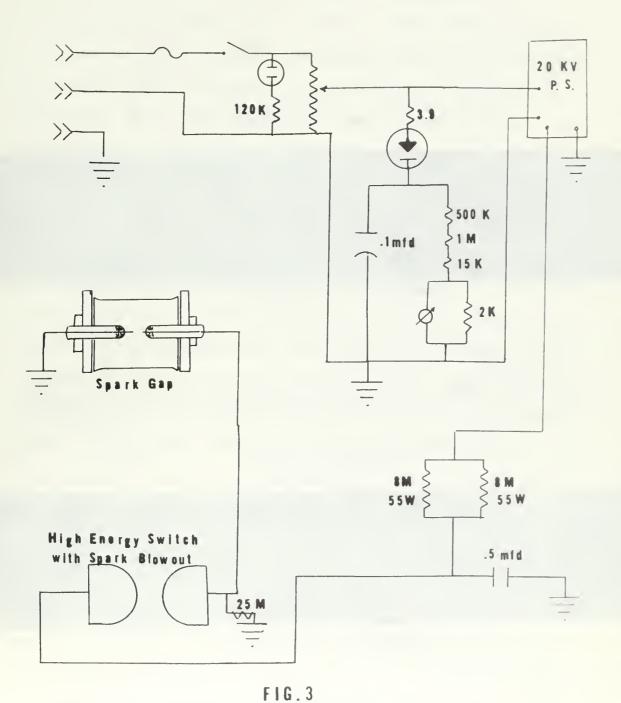


FIG. 2

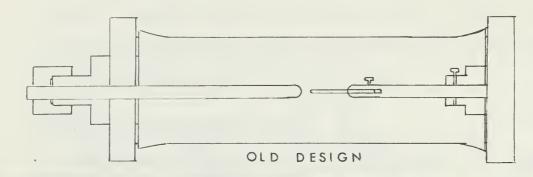
No purging gas was used although there is a capability for purging through a variable leak connected to the vacuum tank vent. The variable leak was utilized in spark source focusing runs to optimize pressures for operation of the vacuum spark gap.

B. SPARK GAP CALIBRATION SOURCE

Positioning and focusing of the new platinum coated grating was accomplished in part through the use of a vacuum spark gap. The apparatus is described in detail by L. E. Kaufman [14]. The trigger circuit was by-passed to produce a free running spark with discharge potential controlled by the spacing of the trigger electrodes (spark gap switch). The circuit schematic (Fig. 3) shows the spark gap system as used. During initial calibration runs it was found that significant losses were developing in the coaxial cable from the air gap switch to the vacuum spark, in corona discharge at the electrode holder, and in secondary discharge between the aluminum end plates of the glass T pipe and the electrodes or between the thinly coated wall of the glass T pipe and the electrodes. The problem was solved by substitution of high voltage coaxial cable and by redesign of the electrode assembly. All possible corona points were eliminated and secondary discharge prevented by use of heavy gauge wire electrodes mounted in glass feedthroughs. The improvement in concentration of the discharge between the electrode pins was significant as shown by comparison spectra in Fig. 4. The number of sparks required to produce equivalent exposures was reduced by a factor of ten.

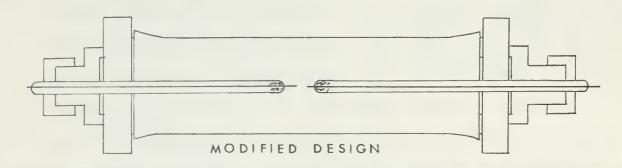


SPARK GAPIONIZATION SOURCE
CIRCUIT SCHEMATIC





TUNGSTEN - ALUMINUM





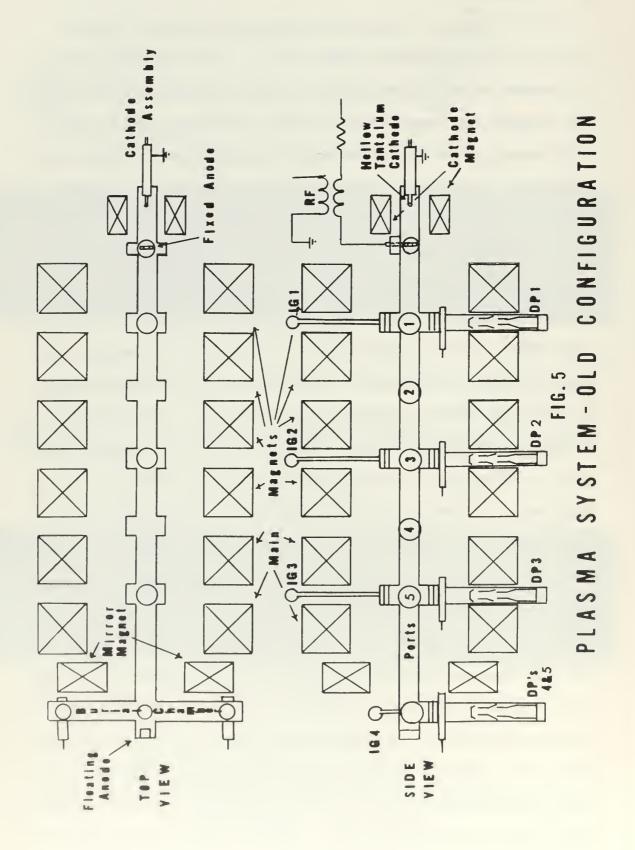
TUNGSTEN - TUNGSTEN

SPARK IONIZATION SPECTRA ELECTRODE DESIGN

C. PLASMA SYSTEM

Initial survey of the nitrogen plasma was conducted with the plasma system configuration shown in Fig. 5. The nitrogen spectrum was scanned at each of the five access ports indicated in the figure. The discharge was operated with a hollow tantalum cathode at ground with respect to the fixed anode held at approximately 100 volts. Arc current was maintained at 60 amps although operation was possible over the range 40 to 120 amps for most conditions of magnetic field and gas supply pressure. At lower currents the discharge could not be maintained. Power requirements and cathode lifetimes set the upper limit. Main magnetic field current was set at 400 amps for the initial runs giving a field of approximately 2400 gauss at the center of the plasma column, as measured with a Hall probe. The field was uniform to within 15% between observation ports #1 and #5. Capability for variation of the magnetic field strength is from approximately 1200 gauss to 10,000 gauss. Neutral gas pressures were measured by an ion gauge positioned above port #3 and varied with the gas supply pressure from 8×10^{-5} mm Hg to 8×10^{-4} mm Hg. Oscillations of the plasma, which persisted for as much as two hours, occurred when the argon starting gas was replaced by nitrogen.

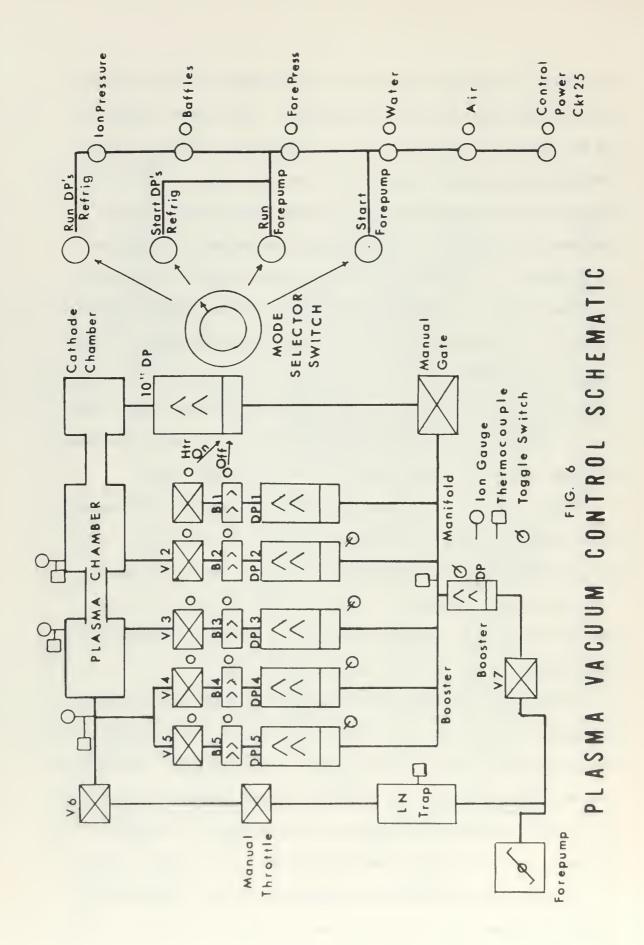
In order to accommodate a theta pinch-generated shock wave experiment the system was altered by insertion of a glass tube with 2 inch I.D. in place of Port #4. A straight section of 4 inch pyrex tube was placed between Port #3 and the anode chamber for use in a longitudinal wave study. Diffusion pump #1 was completely bypassed. The anode-cathode section was redesigned with the anode chamber positioned above a Clark 10" diffusion pump. A large manual gate valve separates the exhaust side of the 10" diffusion pump from the booster manifold,

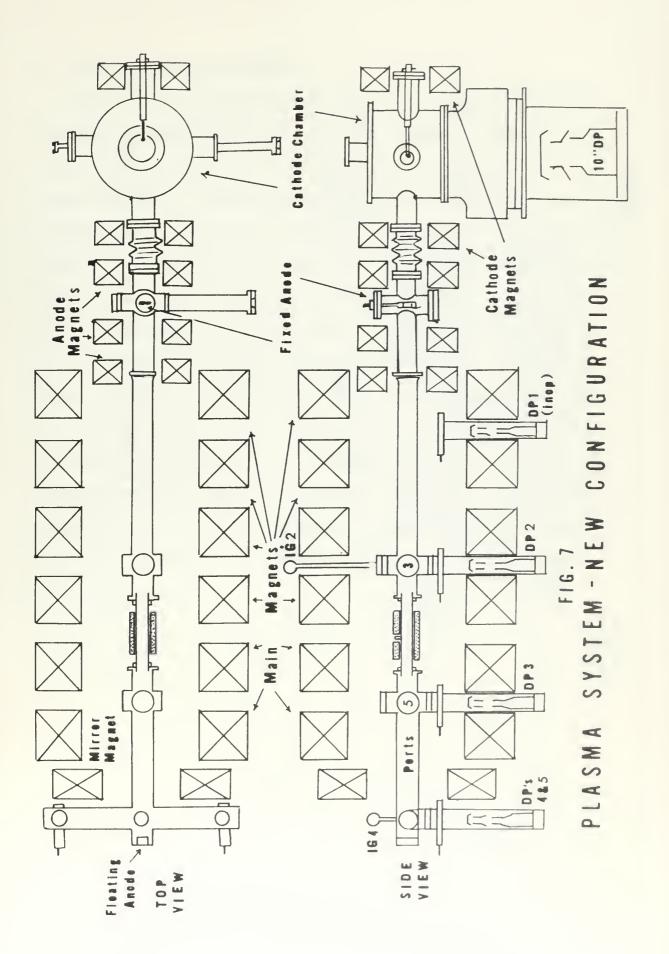


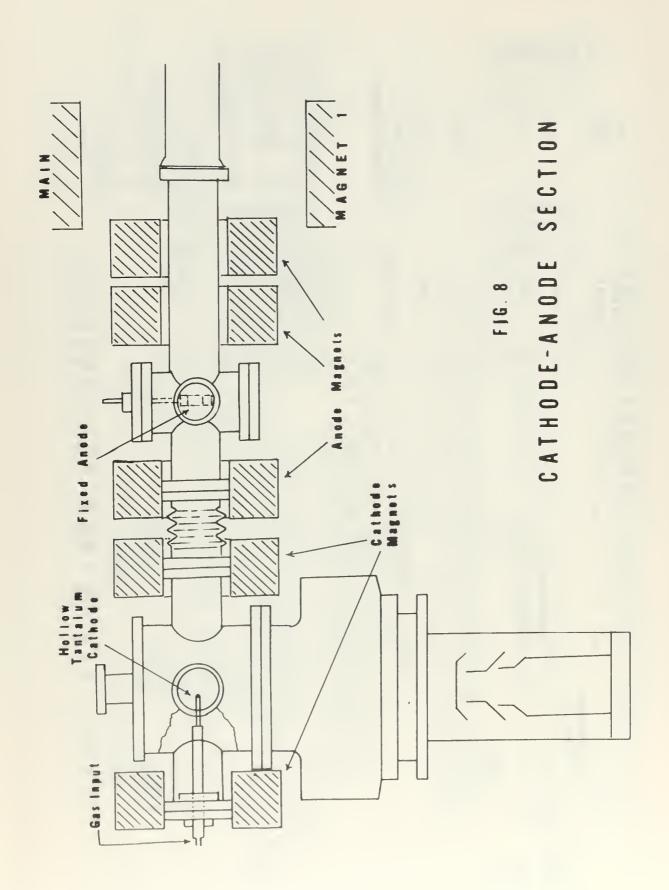
but there is currently no provision for automatic valving between the diffusion pump and the vacuum chamber. This major alteration of the plasma vacuum system made it necessary to develop a set of standardized operating procedures to prevent damage to the diffusion pumps and the vacuum chamber. The vacuum control panel was redesigned as shown in Fig. 6. Operating procedures are presented in Appendix A. A schematic of the new vacuum system configuration is shown in Fig. 7. Details of the anode-cathode section are shown in Fig. 8. As depicted, five new magnets were wound from 1/4 inch square copper tubing for use on both ends of the cathode and anode chambers. When used with the designed number of water paths, each coil is capable of use at 300 amps/40 volts. At present, the number of water paths is reduced, setting a 150 amp current limit.

With the new configuration the system was operated with magnetic field strength varied from approximately 2400 to 6000 gauss. The mirror rectifier was reconnected to the mirror magnet for improvement of plasma confinement. Visible intensities improved slightly and the mirror magnet was set at 1000 amps for a field strength in the vicinity of the floating anode of 5600 gauss.

With the new configuration no instability problems developed on switching from argon to nitrogen, although the nitrogen plasma column was more diffuse than with the previous vacuum system. The previous instabilities appeared to be pressure related although no ranging of the operating parameters affected the instabilities. A possible explanation of the problem was insufficient gas throughput with the old system. The greater pumping capacity has made it necessary to operate with gas supply needle valves wide open and booster manifold pressures three times the previous values.

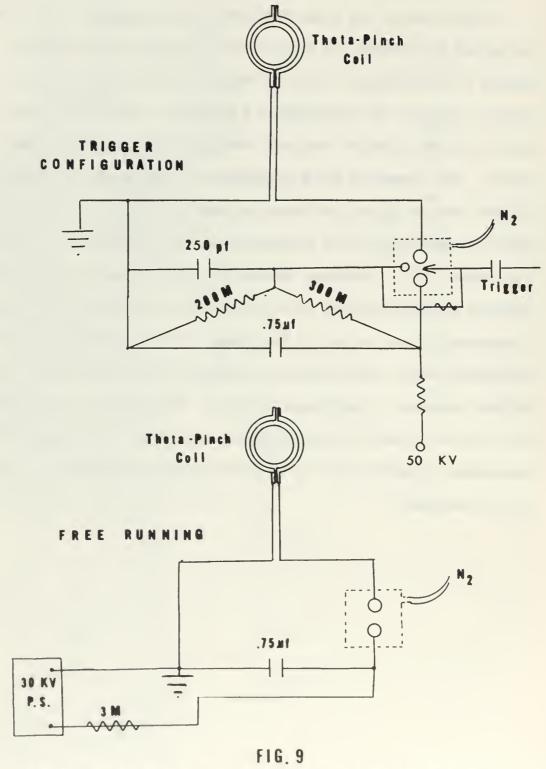




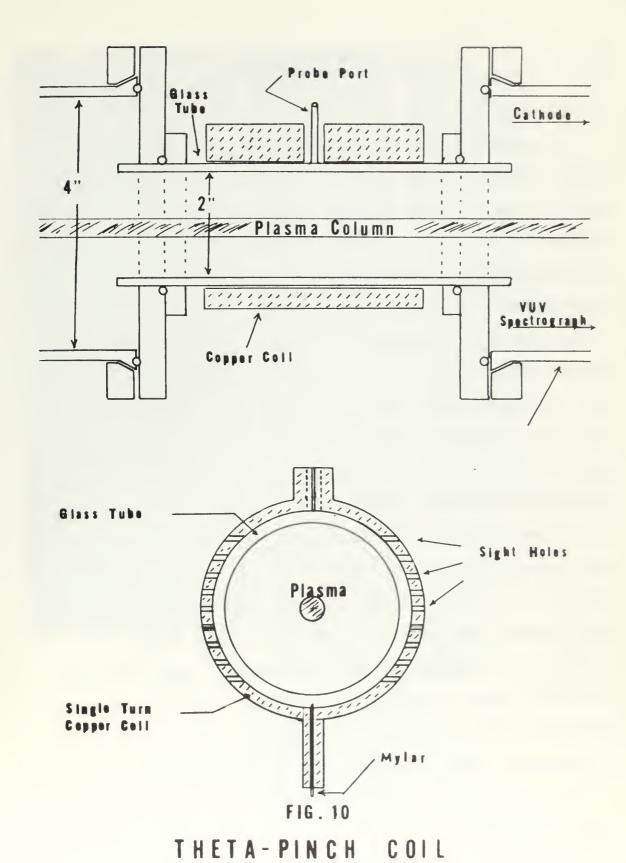


D. THETA PINCH SHOCK GENERATION

Installation of the theta pinch device was completed in May 1969. The system is sketched in Figs. 9, 10. At present the system is capable of discharging a 4.8 x 104 amp, 20 kilovolt pulse with a ringing frequency of approximately 1 megacycle. The pulse is discharged around a single turn coil that is coaxial with the plasma column. The concept of shock generation in this manner is similar to that used in the Scylla device as described by Rose and Clark [15]. Theory of operation of the theta-pinch is best described by Glasstone and Lovberg [16]. Discharge through the coil induces an oppositely directed azimuthal current which with the axial magnetic field causes a compressive force to act on the plasma column. Heating by magnetic compression shows great promise in thermonuclear work although significant problems in confinement develop. The purpose of the thetapinch device in the NPGS plasma system however is to provide a fast compression generated shock wave in conditions qualitatively similar to the ionosphere.



THETA-PINCH CIRCUIT SCHEMATIC



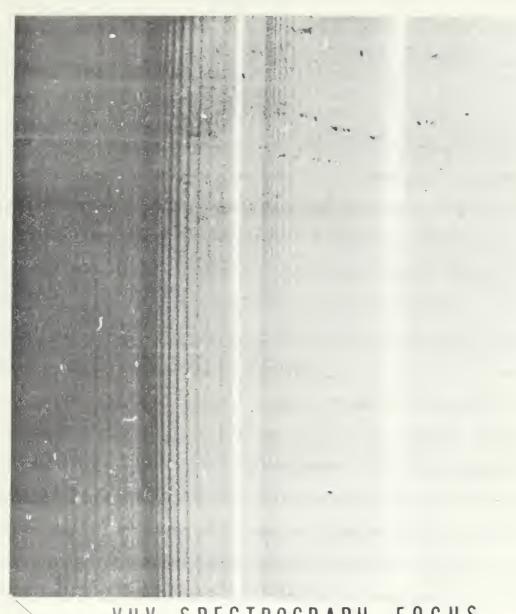
III. EXPERIMENTAL TECHNIQUES

A. INSTALLATION OF GRATING

To improve the operating characteristics of the vacuum ultraviolet spectrograph, i.e., to reduce required exposure times, the previously used uncoated grating was replaced with a platinum coated grating with other characteristics identical. This was accomplished by establishing bench marks while the old grating was in place, then matching the new grating to these conditions. Fine focusing was accomplished using the continuous spectrum of a medium pressure mercury source and adjusting the grating for maximum sharpness of the O2 absorption lines (Fig. 11). Overall focus was then checked in vacuum utilizing a tungsten-aluminum spark source. It became apparent after moving the spectrograph to the plasma source that substantial losses were occurring due to excessive downward rotation of the grating about a longitudinal axis. Observed spectral lines were extremely faint and extended over only a third of the film. The grating was then completely repositioned using a cathetometer in conjunction with a continuous beam laser to make coplanar the Rowland circle established by the grating and the plane established by the film holder. Extension of the Rowland circle permitted using the Hg green line as a focus check. Final focus was as above with the absorption spectrum and the tungsten-aluminum spectrum.

Major problems developed in the spark gap calibration source.

Losses as described in the previous section in the coaxial cable and in stray discharge inside the glass T-tube reduced the efficiency of



VUV SPECTROGRAPH FOCUS

02 ABSORPTION LINES



FIG. 11

the spark to the point where adequate calibration runs could not be made. Redesign of the electrodes and the power input system allowed exposures with ten or fewer sparks as compared to three hundred sparks giving barely usable results.

B. OPERATION OF VACUUM SPECTROGRAPH

Vacuum system operation is described in Appendix B. Alignment of the optical system with the central core of the plasma column was possible through trial and error exposures. A small degree of anastigmatism allowed centering of the spectral lines. The vacuum coupling of the spectrograph to the plasma system was modified to allow coupling at each of the five ports along the plasma column. Exposures were made for varying background pressures as set by varying the gas supply pressure. Exposure times ranged from thirty seconds at Port #1 (nearest the cathode) to ten minutes at Port #5 (next to the floating anode), for comparable results. Modification of the plasma vacuum system restricted the location of the spectrograph to Port #3, the plasma midpoint. At this port studies were made of the nitrogen plasma at magnetic field strengths from 2400 to 6000 gauss with the mirror magnet set to 1000 amps (5600 gauss) or turned off. Visible intensities increased at lower magnetic field strengths with the mirror magnet on, as expected.

C. SPECTRAL ANALYSIS

Calibration of the nitrogen spectrum was accomplished by comparison with previously identified helium spectra taken on the P-4 device and on the NPGS reflex arc. A sufficient number of lines was identified to allow fitting of the remaining comparator-determined positions to a

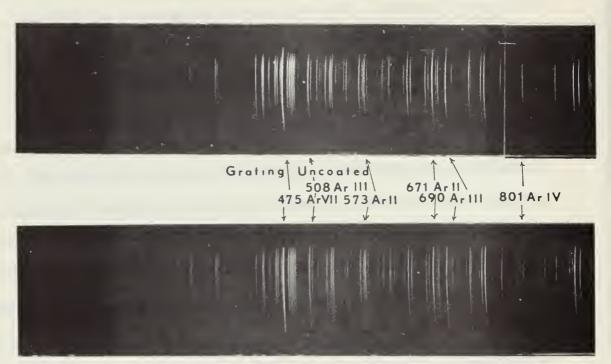
six degree polynomial. The nitrogen-helium spectrum is shown in Fig. 12 with complete identifications presented in Appendix C. Cross reference to this spectrum allowed identification of the nitrogen spectrum shown in Fig. 13 with identifications in Appendix D. For information only, argon spectra are shown in Fig. 14 from the previous and present gratings. Some improvement in sensitivity with the new grating is noted although relative exposure data are not available.

Density information was obtained by scanning the film with a Leeds and Northrup recording microphotometer using a Speedomax recorder. The density data were utilized in calculating electron temperatures by converting the data to intensities with an equation given by Harrison, Lord, and Loofbourow [15],

$$I_2 = I_0$$
 antilog₁₀ $[(D_2 - D_0)/\gamma]$

where γ is the contrast of the photographic emulsion measured by the tangent of the density versus log intensity curve (commonly called the "H & D" curve). For the conditions under which the Kodak SWR film was used, gamma is estimated to be 1.6 for monochromatic exposure at 758 Å [16]. This estimate is based on the Kodak published density-log intensity curve, not on any published SWR gamma tabulations.

Background studies of nitrogen in preparation for the spectral survey included drawing of Grotrian diagrams for NI, NII, NIII, and NIV. The source for atomic energy levels was principally C. E. Moore [17]. Transition data were obtained from Moore [18], Kelly [19], Wiese, Smith, and Glennon [12] with supplementary references mentioned by these sources checked. Emphasis was given to vacuum ultraviolet transitions although prominent visible transitions between many of the lower lying levels are included. The diagrams are presented in Appendix E.



Platinum Coated

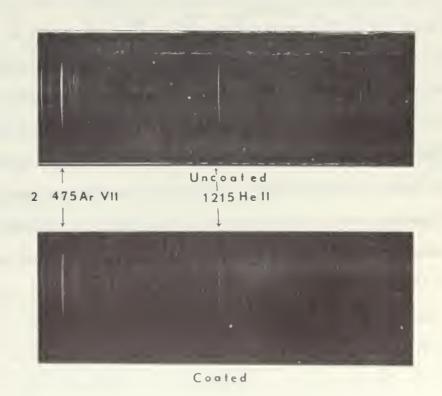


FIG. 14

ARGON SPECTRA

D. PLASMA SYSTEM OPERATION

A number of problems remain unresolved with respect to operation of the plasma system. Lifetime of the hollow cathode has not improved with modification of the cathode assembly. Average lifetime of five cathodes used since completion of the new assembly was 8.03 hours as compared with an average lifetime in the old system of 10.0 hours. Failure of the cathode with one exception has occurred approximately 1.5 cm from the tip, suggesting reflected bombardment of the outside of the cathode or magnetic focusing at this point. Evaluation of the cathode life with anode magnet off operation is not complete. The first cathode used in this manner lasted for 20.37 hours, and appeared to be in excellent condition at 14.00 hours with a very slight ablative necking down over the first 1.5 cm of the cathode. It is expected that operation in this mode will substantially improve the cathode lifetimes. Reasons for using the anode-off operation are discussed in the following paragraph.

Although nitrogen plasma instability problems were not apparent in the new vacuum system, the entire plasma column was very diffuse with diametric extent of 8 cm. It was discovered by the author that operation of the system with the anode magnets off increased the stability of the plasma, narrowed the beam diameter to 1 cm, and greatly increased visible intensities. Alignment of the anode magnets on the plasma system longitudinal axis and magnetic field direction were checked and found to be in order. A possible explanation of this phenomenon may be a mirroring effect which results in major plasma confinement between the cathode and the fixed anode. Additionally, improper focusing of ions at the cathode would have a disruptive effect

on the entire beam. Background pressures measured with an ionization gauge above Port #3 indicate an increase of neutral pressure from 3.8×10^{-5} mm Hg to 1.2×10^{-4} when the anode magnet is energized.

E. THETA-PINCH SHOCK WAVE STUDY

Operation of the theta-pinch shock perturbation experiment installed on the plasma system was first achieved on 6 May 1969. The pulse was triggered initially with the plasma chamber at atmospheric pressure. Visual observations were made with the plasma arc not in operation at pressures from 100 microns to 0.5 microns. Observation of the plasma column with the shock pulse in operation is presently being conducted. Diagnostics used to date with both plasma system and shock perturbation in operation include; 1) visual observation of the plasma column for large scale intensity variation, 2) scanning of spectral lines with photomultiplier tubes at the exit slit of a dual beam monochromator, 3) oscilloscope investigations with photomultiplier tubes at the plasma system and isolated by use of light pipe, 4) Langmuir probe analysis, 5) comparison spectra produced by the vacuum ultraviolet survey spectrograph. Results are reported in the next section.

IV. OBSERVATIONS AND RESULTS

A. NITROGEN PLASMA SPECTRUM

Identifications of 735 lines were made from the nitrogen-helium spectrum and are reported in Appendix C. Of these the more intense nitrogen lines arise from NIII, with NII secondary in numbers and intensities of lines. No attempt has been made to correct the intensities for spectral sensitivity variation of the film or spectrograph. It is noted that there is a general diminishing of the number and intensity of spectral lines below 400 A and above 1600 A. Resonance lines of NV,1238.821 and 1242.804, appear on the nitrogen-helium spectrum, but not on the nitrogen spectrum. result most likely arises from an energy transfer from helium ions and electrons in the helium plasma to nitrogen contaminants. In the nitrogen plasma this energy might be self-absorbed by the lower lying species NII and NIII, or dissipated in collisional recombination. Of nitrogen's seven ionization states, NI, NII, NIII, NIV, and NV are believed to have been observed. Impurities included carbon, oxygen, argon, and possibly helium and silicon.

B. RELATIVE LINE INTENSITIES

In an effort to establish a radiation model for the plasma, both the Local Thermal Equilibrium model and the Corona model were linearly combined. With temperature inputs from 4.0 eV to 8.0 eV, markedly different intensities were calculated for LTE versus Corona models. Results for a group of 21 lines in the range 529.4 Å to 672.0 Å are shown in the table on the following page. The intensities show slight sensitivity to variation in model and pronounced sensitivity to changes

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Electron Temperature : 4.0 eV

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Electron Temperature : 8.0 eV

in electron temperature. As the model approached 100% Corona, relative intensities doubled in most cases. With increasing electron temperature, the relative intensities decreased but not as sharply as with model variation.

The most obvious use of the calculations or similar ones in the visible spectrum is to determine which radiation model is more appropriate for any given ion species. To accomplish this an accurate independent measurement of electron temperature must be made. Intensities from the model mix calculations should then pinpoint the correct model, or show that a certain linear combination gives satisfactory results. A further result would of course be more accurate determination of absorption oscillator strengths.

Another possible use of the model mix is for intensity predictions over a wide wavelength range. The drawback to accurate intensity predictions at the present time is again lack of precise values for the absorption oscillator strength.

C. ELECTRON TEMPERATURE EVALUATION

Initial results from density information in the vacuum ultraviolet produce wide variation in electron temperature. Values were uniformly spread over a range of 1.0 eV to 12.0 eV. Work is continuing in this area, although oscillator strengths in the vacuum ultraviolet region may vary as much as 40-50% even within the same multiplet.

The preliminary VUV density results prompted further investigation in the visible region. Using the unpublished intensity measurements made by Major J. Cote using a dual beam spectrophotometer, electron temperatures were calculated using the Corona model. The results for various magnetic field strengths are presented below.

Magnetic Field	LTE	CORONA
2400 gauss	3.8473 eV	7.3384 eV
3000	3.8650	7.3725
3600	5.5496	19.663
4200	measurements	inconsistent
4800	4.4115	9.7736

It is believed that the Corona values are more nearly correct in view of the large violation of the LTE validity criterion. The value for 3600 gauss is questionable in view of the tendency of the electron temperature equation to become indeterminate for very small values of the logarithmic term in the denominator.

D. THETA-PINCH PERTURBATION

No visible effects have been noted on the plasma column due to the theta-pinch discharge. Ionization of both argon and nitrogen has been achieved with the chamber pressure between 100 microns and 4.8×10^{-4} mm Hg. Below this pressure, effects of the shock pulse were not seen with the reflex arc off.

Attempts to observe the shock with the spectrophotometer were equally unrewarding. Minor oscillations were determined to be extraneous pickup of the trigger signal in the pressurized spark gap switch. RF discharge has been noted at all locations in the plasma laboratory including sparking between wires of a diagnostic coil placed near the single coil theta-pinch device. Attempts to filter the RF signal are in progress. Probe signals showed pickup of the trigger signal but no useful information on perturbations within the plasma column.

The first possible indication of variation of the plasma column was picked up on 19 May 1969, by a remote photomultiplier connected to the plasma tube by a light pipe. The signal to the oscilloscope was

directly related to the spark of the trigger gap although the signal was not noted every time the spark trigger indicated discharge through the theta-pinch coil. The signal showed a rise time of slightly less than 1 microsecond and an amplitude approximately 2.5 times the noise amplitude. Confirmation that the signal was indeed from the plasma was based on complete shielding of the light flash from the trigger spark (signal still received) and closing of the photomultiplier shutter (signal off). The rise time corresponds to design predictions of a one megacycle frequency for the discharge. That the shock front cannot be seen visibly in spite of the size of the signal may be attributed to the speed of the shock front estimated at 10⁷ cm/sec.

On verification that a perturbation existed within the plasma column, an attempt was made to observe the effect in the vacuum ultraviolet spectrum. Subsequent exposures under identical conditions of plasma operation showed no difference in the spectrum exposed during theta-pinch perturbation.

V. CONCLUSIONS AND RECOMMENDATIONS

A. SPECTROGRAPHIC ANALYSIS

Spectral survey of the nitrogen plasma in the vacuum ultraviolet was valuable because it was a previously uninvestigated area of the NPGS reflex arc spectral characteristics. Considerable information on the steady state plasma system must be available prior to attempting meaningful diagnostics on a shock-disturbed plasma.

Lack of concise electron temperature information from photographic intensities was partly expected. The large variation in the spectral response of SWR film, unknown wavelength-dependent response of the spectrograph, and lack of temperature control processing make quantitative spectral analysis difficult in this region. Values of absorption oscillator strength for transitions in the ultraviolet are known only within 40% at best. Expected electron temperatures are in the same range as the excitation potential difference, so any change of this magnitude in the logarithmic term would greatly alter the calculated electron temperatures. Some overlapping of spectral lines prevented utilization of certain wavelengths with recent oscillator strength values. From computer analysis it was determined that electron temperatures (or intensities for the inverse equation) are very sensitive to values of absorption oscillator strength and statistical weight.

Close agreement of photometric data with probe measured values appears reliable, although use should be made of the corona radiation model.

B. TIME RESOLVED PHOTOMETRY

There is a definite need for time resolved photometric observation of the plasma. This may be accomplished most easily by oscilloscope/ spectrophotometer observation in the visible region. If observations establish that response is inadequate in this region, then consideration should be given to developing time resolution capability in the vacuum ultraviolet. Since the most intense lines occur in this region, response to perturbations should be larger. Experimental difficulties of work in the vacuum ultraviolet make complete quantitative spectral analysis in the visible spectral regions a first priority. Further investigations in the vacuum ultraviolet should be conducted only when it appears that spectral line intensities in the visible region are not sufficiently sensitive perturbation indicators.

C. VUV SCANNING MONOCHROMATOR

Difficulties in preventing contamination of bare photomultiplier tubes, and in scanning over the desired wavelength range make construction of a vacuum ultraviolet monochromator extremely difficult. Desire to maintain capabilities in the extreme vacuum ultraviolet requires grazing incidence. Any deviation of components of a grazing incidence spectrograph results in large scale defocusing. The most practical, although initially more expensive, solution is purchase of a commercially produced grazing incidence scanning monochromator. The returns from such an instrument would justify the expenditure. Of those instruments and designs investigated the McPherson 2 meter grazing incidence monochromator [19] appears to be the best design.

D. MAGNETIC FIELD SURVEY

It is imperative that a complete survey of the magnetic field of the plasma system be undertaken as soon as possible. Existing Hall probe measurements are inadequate and rather limited as to range of mirror, main, anode, and cathode field variation. Particular attention in the vicinity of the anode-cathode section would go far toward solving the anode magnet instability problem.

E. SPARK GAP SPECTRAL STUDIES

The remarkable improvement in the efficiency of the spark gap calibration source suggests its use for further spectral studies of the higher ionization states of all electrode materials. The simplicity of the design requiring only glass tubing and heavy gauge wire permits convenient phasing from one spectrum to another or operation with test electrode and calibration electrodes together.

APPENDIX A

PLASMA OPERATING INSTRUCTIONS

I. Evacuate Chamber

- A. Evacuate Foreline:
 - 1. Preliminary checklist:
 - a. Control power Ckt 25 ON
 Air interlock switch ON
 Water interlock sw ON
 Mode switch START FOREPUMP
 Foreline relay meter Set at 30 u
 - b. Check compressor air pressure at approx. 70 psi (CAGE).
 - c. Check following valves CLOSED:

V2 through V6 (Gate valves)
Foreline vent valve
Booster manifold vent valve
Foreline gate valve to 10 " DP

- d. Check the following valve OPEN: V7 (Booster gate valve).
- e. Check system water valve OPEN: Pressure approx. 40 psi.
- f. Check forepump water valve OPEN at forepump (identified by wire looped through handle). Adjust for slow steady stream of water.
- 2. Press Forepump START button at the control wall. Foreline and Booster manifold pressures should drop to 20 u in approx. two (2) minutes.
- 3. Set booster relay meter at 500 u.
- 4. When forepump relay meter has locked, press forepressure interlock button. The interlock light should glow.
- 5. Turn Mode switch to RUN FOREPUMP position.
- B. Pump Out Chamber (Rough Pumping/High Vac)
 - 1. Check boiler cooling water to 10" DP OFF.
 - 2. Turn ON Ion Gauge Controller Power & Stand-by Control Power.

I. Evacuate Chamber (continued)

- 3. Open manual throttle valve at machine.
- 4A. If chamber is at atmospheric, with DP's OFF:
 - a. CLOSE V7 & V6.
 - b. Close manual throttle valve.
 - c. Open V6.
 - d. Gradually open manual throttle and observe forepump exhaust for normal levels of water vapor.
 - e. Pump down to 80 u.
 - GO TO STEP 5 IMMEDIATELY!
- 4B. If chamber is at atmospheric, with DP's ON:
 - a. Complete steps in 4A, but leave mode selector switch on START DP's & REFRIG.
 - b. GO TO STEP 5 IMMEDIATELY, BUT OMIT STEPS 9, 11.
- 4C. If chamber is at 500 u, with DP's OFF:
 - a. Close V7, Open V6, Pump down to 80 u, (indicated on TC2).
 - b. GO IMMEDIATELY TO STEP 5.
- 5. OPEN V7.
- 6. START Argon purge at cathode to maintain 80 u (TC2) Note: usually wide open on the argon needle valve.
- 7. OPEN foreline 10" DP Gate Valve, CLOSE V6.
- 8. Check water flow to 10" DP: Boiler cooling OFF; DP Inlet, DP Outlet, Baffle Cooling ON.
- 9. Procedure for starting diffusion pumps (DP's) and refrigeration:
 - a. Check Refrigeration Toggle switch OFF.
 - b. DP Toggle switches may be left ON.
 - c. Turn Mode Selector switch to START DP's & REFRIG.
- 10. Turn 10" DP Heater ON.

I. Evacuate Chamber (continued)

- 11. Individual DP Heater switches may now be turned ON (if not already ON).
- 12. Record starting time in Vacuum Log.
- 13. Turn Refrigeration Toggle switch ON. Allow approximately ten (10) minutes for cooling.
- 14. Allow twenty (20) minutes for warm-up.
- 15. When chamber pressure begins to drop (indicating DP's pumping), secure the Argon purge and note the time. Pressure should drop to less than 1 u.
- 16. Set Booster Relay to 100 u. Press baffle interlock button.
- 17. High vacuum procedures may be commenced when the 10" DP has started pumping. Check that the following conditions exist prior to high vacuum pumpdown:
 - a. Ion gauge controller power ON, pressure multiplier at 10^{-4} .
 - b. Chamber pressure should be below 1 u.
 - c. Ion gauge standby control power ON, filament toggle switches in ON positions (as needed), Outgas switches OFF.
 - d. Start ion gauge by simultaneously pressing:
 - 1. Filament ON (Ion gauge controller)
 - 2. Reset (Ion gauge standby controller)
 - e. The diffusion pumps (DP's) should have heated at least twenty minutes. Check cooling water temperatures.
 - f. Baffle signal light (interlock) should be ON.
 - q. Check V6 CLOSED, V7 OPEN.
- 18. If these conditions exist, OPEN valves V2 through V5, and note time in the Vacuum Log. If the opening of any valve causes a pressure rise allow more warm-up time for that diffusion pump with the valve closed.
- 19. Record pressures/time at 1 min, 2 min, 4 min, etc., and plot on log-log coordinates in order to judge the condition of the pumpdown and freedom from leaks. The zero (starting) time will be taken as the time when the argon purge is secured.

20. Turn Mode Selector switch to RUN DP's & REFRIG for operation protected from pressure rise. A pressure exceeding 1.5 x the full scale ion gauge reading will cut OFF the ion gauge, ion gauge standby control, close valves V2 through V5, and cut OFF the DP's.

II. Magnet and Arc Operating Procedures

A. Preliminary

- 1. Set Booster Relay to 500 u.
- 2. Start Argon gas flow to the cathode, set initially at 3×10^{-4} .
- 3. Fill pure water:
 - a. Close de-ion loop valve.
 - b. Open main water valve 3/4 to 1 turn and fill until overflow observed.
 - c. Secure main water valve.
 - d. Reopen de-ion loop valve.
- 4. Turn OFF Ion Gauge #4 (Reflex Anode)
- 5. Remove watches, warm personnel, inspect for tools lying around machine.

B. Energize magnets:

- 1. Connect blower at reflex anode.
- 2. Start Pure Water followed by Raw Water. Allow two minutes for stabilization of pressures.
- 3. START cooling tower. Check to ensure its operation.
- 4. Observe water flow in all flow meters and check hoses for flow and leaks.
- 5. Turn ON Control Power CKT 21, Push 3 interlock buttons.
- 6. START Control Power CKT 19 (if it kicks out, reset circuit breaker, then restart).
- 7. START Control Power CKT 23. (Both CKT's 19, 23 usually left ON).
- 8. Turn Mirror Magnet Rectifier Power switch ON (located in shed nearest the door).

II. Magnet and Arc Operating Procedures (continued)

- 9. START other rectifiers by turning ON Standby switch at console. The operation of the rectifiers is verified by the roar of the rectifier fans.
- 10. Consult magnet chart for operating conditions to give desired field, switch ON appropriate number of units at the console. Have been starting with #3 ON, rheostat at 65% to give 400 amps in the main magnets.
- 11. Press START buttons to start magnet current (separate buttons for mirror, main, anode, and cathode magnets).
- 12. Record time of start in Magnet Log Book.

C. Energize Arc

- 1. Start R-F. If not observed increase pressure until it is observed.
- 2. Press both Arc ON buttons simultaneously.
- 3. On start, immediately reduce #2 Anode Voltage Control rheostat to obtain an arc current of 60 amps.
- 4. Remove R-F.
- 5. Adjust magnet fields, supply flow, as needed reset anode voltage control for arc current 60 amps.
- 6. To switch to another gas, OPEN other needle valve until flow observed on the ion gauge, then continue opening while securing the Argon needle valve.

III. Shutdown Procedures

- A. Arc and Magnets:
 - 1. Arc OFF.
 - 2. Main, mirror, anode, cathode magnets OFF.
 - 3. Secure gas flow.
 - 4. Control Power CKT 21 OFF.
 - 5. When all water cooling return lines are cool (check anode magnets in particular); a) Secure cooling tower, b) Raw Water OFF, c) Pure Water OFF.
 - 6. Standby Switch OFF (Secures rectifier fans).

III. Shutdown Procedures (continued)

- 7. Turn Mirror Magnet Rectifier Power switch OFF (located in shed, nearest door).
- 8. Reflex anode blower OFF.
- 9. Lock cooling tower cage.
- B. Chamber Secure to 500 u with overnight defrost. If desirable to bring chamber to air, see Section III C.
 - 1. Set Mode Selector Switch to START DP's & REFRIG.
 - 2. Close gate valves V2 through V5.
 - 3. START Argon flow open to 80 u as indicated to the Booster Relay TC (usually wide open).
 - 4. 10" DP Heater OFF.
 - 5. Open Booster Cooling Water valve Note time.
 - 6. Refrigeration switch OFF.
 - 7. DP Heaters OFF.
 - 8. Mode selector switch to RUN FOREPUMP.
 - 9. Wait 10 minutes after TC2 indicates pumping action stopped.
 - 10. CLOSE 10" DP Gate Valve.
 - 11. Secure Argon flow at 500 u.
 - 12. System is now shutdown for overnight with defrost. To pump down from this condition, start at I-B-l using part I-B-4C.
- C. Chamber Secure chamber to atmospheric with vacuum maintained on booster manifold.
 - 1. Set Mode Selector switch to START DP's & REFRIG.
 - 2. CLOSE gate valves V2 through V5.
 - 3. Start Argon purging flow open to 80 u on Booster Relay TC (Argon needle valve usually wide open).
 - 4. Turn 10" DP Heater OFF.
 - 5. OPEN Boiler Cooling Water valve Note Time.

III. Shutdown Procedures (continued)

- 6. Wait for 10 minutes after TC2 indicates pumping action stopped.
- 7. CLOSE Foreline Gate Valve to 10" DP.
- 8. Start main nitrogen purging through system vent valve.
- 9. Secure Argon purge through cathode.
- 10. Secure vent valve when manometer indicates atmospheric.
- 11. Secure nitrogen vent supply.
- 12. System is now in condition of temporary secure. Work on chamber and related components now possible. To pump down from this condition, start at I-B-1, using part I-B-4B. If it is desired to go ahead and secure the DP's proceed to the next step.
- 13. Turn OFF Refrigeration toggle switch.
- 14. Turn OFF DP Heaters.
- 15. Move Mode Selector switch to RUN FOREPUMP.
- 16. Set Booster Relay meter to 100 u.
- 17. Chamber is now in condition of temporary secure with DP's and Refrigeration OFF. To pump down from this condition start at I-B-1, using part I-B-4A. If complete shutdown is desired proceed to the next step.
- 18. Turn OFF Forepump. System is self venting. If immediate venting desired, OPEN Foreline Vent valve.

APPENDIX B

VUV SPECTROGRAPH OPERATION

- A. Vacuum Procedures.
 - 1. Operation with roughing pump only:
 - a. Check all valves closed; pressures equalized.
 - b. Power to all circuits.
 - c. Thermocouple ON.
 - d. If operating with spark gap, open shutter valve 1/2 open. If operating with plasma, leave valve closed. Insert film and secure back plate.
 - e. Start forepump.
 - f. Open red handle throttle valve.
 - g. Pump down to approximately 50 microns (about 5 min.)
 - h. UV Spectrograph vacuum system is now ready for spark gap operation.
 - 2. Operation with roughing and diffusion pumps.
 - a. Complete steps as listed above.
 - b. Connect water inlet and drain.
 - c. Connect ion gauge commence warm-up.
 - d. At approximately 50 microns:
 - (1) Close roughing valve.
 - (2) Open foreline valve.
 - e. Turn ON diffusion pump.
 - f. Warm-up 20 minutes.
 - g. Fill IN Trap 2/3 full (about 3 liters).
 - h. Turn ion gauge ON.
 - (1) Set pressure range selector to 10⁻⁴.
 - (2) Adjust zero.

VUV SPECTROGRAPH OPERATION (continued)

- (3) Gauge filament ON.
- (4) Meter selector to I_g adjust I_g to 1 ma.
- i. Close foreline valve.
- j. Open roughing valve. Pump down to 10 microns.
- k. Close roughing valve.
- 1. Open foreline valve.
- m. Open DP Gate valve.
- n. System is now ready for full vacuum operations. If the plasma system is under comparable vacuum, the shutter gate valve may be opened as desired for exposures.
- o. To recycle films with plasma and VUV systems in operation:
 - (1) Close shutter valve.
 - (2) Close DP gate valve.
 - (3) Vent chamber of VUV Spectrograph to atmosphere.
 - (4) Change films.
 - (5) Secure vent, close foreline valve.
 - (6) Open roughing valve to rough down chamber to 100 microns.
 - (7) Close roughing valve.
 - (8) Open foreline valve. Check that foreline is at 10 microns or less.
 - (9) Open DP gate valve.
 - (10) System is now ready for further exposures.

APPENDIX C

NITROGEN - HELIUM SPECTRUM

Wavelength	(Å)	Identification	Wavelength	(A)	Identification
197.230 205.960 225.136 225.205 230.139 230.686 231.454 232.584 234.347 237.331 238.361 238.573 239.618 240.979 241.037 243.027 244.049 244.907 247.205 248.618 256.317 256.425 256.460 256.506 259.542 260.455 261.027 263.818 264.837 264.837 264.837 264.837 264.837 264.837 264.837 264.837 264.837 264.837 264.837 264.837 264.837 264.837 264.837 265.506 259.542 260.455 261.027 263.818 264.837 264.837 264.837 265.506 259.542 260.455 261.027 263.818 264.837 265.506 259.542 260.455 261.027 263.818 264.837 265.506 259.542 260.455 261.027 263.818 264.837 264.837 265.506 267.030 268.451 270.583 272.125 272.311 274.051 275.513 277.385 280.043		N IV N IV N IV N IV N IV He II He II He II He II He II He II O IV N IV O III C IV N IV O III C III	282.213 283.579 284.346 289.230 291.054 291.263 291.326 292.447 292.595 294.650 295.657 296.951 297.815 299.820 303.783 303.891 304.032 304.874 304.912 305.596 305.656 305.769 305.879 305.879 305.879 305.879 305.918 310.1697 311.628 312.422 312.453 314.715 314.877 315.053 314.715 314.877 315.053 319.266 320.392 320.979 321.161 322.503		N III N IV N III C IV D IV C IV C IV N IV N III

Wavelength	O (A)	Identification	Wavelength	O (A)	Identification
322.570 322.5741 322.724 323.431 323.488 323.615 327.176 328.448 328.742 332.133 332.327 335.050 341.143 341.179 341.242 345.309 347.777 347.854 351.979 358.578 358.740 359.223 359.384 360.675 362.881 362.881 362.946 363.7852 36		N IV C III N IV N III N III N III N III C	374.165 374.204 374.331 374.436 374.441 377.045 379.574 384.032 387.353 388.9687 389.0045 389.0898 391.943 392.002 392.322 395.558 397.120 398.885 399.045 399.084 399.637 399.688 403.273 409.325 411.9577 418.705 419.525 419.525 419.525 419.525 429.557 429.647 429.557 429.647 429.557 429.647 429.716 430.041 430.177 433.3391 434.014 434.066 434.129 434.266 434.280		O III N III O III O III O III O III O III O III C IV C IV N IV C III C III C III O II O II O II O II O

Wavelength ((A) I	dentification	Wavelength (A)) Id	•ntification
434.646 434.840 434.975 436.510 436.649 437.332 437.683 440.552 440.598 442.048 443.42 445.601 445.638 446.949 447.527 449.065 449.493 450.079 450.44 450.7338 451.20 451.869 452.226 452.91 452.92 453.340 456.997 459.633 460.0487 463.737 464.785 466.491 466.9 468.766 470.408 472.332 473.025 473.025 473.918 474.891 475.647 475.698 475.698 475.698 475.803	A C A N N A A N N O C C C C A N D C A D D N N A	III III III III III III III III III II	475.884 476.43 477.6246 480.955 481.354 481.381 482.548 483.567 483.618 483.733 483.976 484.025 484.116 484.445 485.465 485.515 485.572 485.631 487.025 487.988 488.452 489.195 492.6500 493.341587 495.55 406.91 499.425 499.583 499.871 500.343 501.01 505.986 506.153 507.391 507.683 507.391 507.683 507.391 507.683 508.6341	NACOODACCCOGAAGOGGAAAGCAAGCGGANNNOOO HANNNOHHA.	

0 Identification Wavelength (A) (A)Identification Wavelength 515.6165 He I 555.056 0 II 0 II 515.640 555.121 0 ΙI II 555.262 0 517.937 0 IV 518.242 0 ΙI 556.8172 Ar II I 522.2128 He 556.893 Ar III V 558.321 524.189 Ar Ar III III G 525.795 559.48 Ar 527.693 Ar V 559.762 ΙI N H 528.6508 Ar 560.2394 C ΙI ΙI C 529.355 N 560.4367 ΙI N C 529.413 IΙ 564.608 II 529.491 N ΙI 564.663 C II C 529.637 N II 565.5280 III ΙI 2×283.420 529.722 N N IV ΙI 2 529.867 N $\times 283.470$ N IV N III 2×283.579 N IV 530.037 530.268 N III 572.069 N ΙI C ΙĪ 573.3622 532.659 Ar II C 532.705 II573.468 Ar III 533.511 N II 574.2809 C III ΙI 533.581 N 574.650 N II N ΙI 574.799 5i III ?? 533.650 533.729 N II 578.1068 Ar II 578.386 III N II Ar 533.815 579.212 Ar III 535.0713 Ar II 535.2885 580.2634 Ar II III C 535.580 580.400 0 II Ar III 580.967 0 II 536.745 Ar III 537.0296 582.156 N II He I 537.830 584.334 He Ι ΙI 0 538.0801 585.261 C III C III 585.417 538.1487 C C III III C 538.318 585.496 III 0 II C 539.086 0 585.608 III II 539.547 ΙI 585.666 C III 0 543.444 591.4117 H. Ι C II 546.1770 C II 594.8000 Ar II 547.4602 595.0219 \mathbb{C} II II Ar 548.7810 C 595.0245 II H Ar 549.3195 U III C II 597.818 549.3785 599.598 C C III II 549.5110 C 600.251 C II II 549.5700 C 600.337 \mathbb{C} II II 551.874 C C 600.353 II II 553.328 600.503 C II 0 IV 554.074 C ΙI 0 IV 600.518 554.514 0 IV 600.585 0 IΙ 554.655 C III 601.468 III

Wavelength (A) Identification Wavelength (A) Identification 601.878 673.768 N III G ΙI 602.8581 Ar ΙI 679.4001 II AF 683.278 604.152 Ar ΙI Ar IV 2×303.783 III II 684.996 N He 608.395 0 IV 685.513 N III 609.275 C 685.816 III III N 609.705 0 686.416 C ΙI III C ΙI 610.043 0 III 686.488 C 610.746 0 687.0526 H III C 610.850 0 III 687.345 ΙI С 616.291/616.363 687.352 II0 II? 689.007 Ar IV 617.051 0 ΙI 622.144 C 690.170 Ar III III III624.617 0 IV 690.526 C 625.130 691.187 III 0 IV N N III 625.852 0 IV 691.388 Ar III 629.167 N II 695.537 629.447 N II 697.4893 Ar II 0 V Ar II 629.732 697.9414 N II Ar IV 635.197 700.277 C ΙI 635.9945 702.332 0 III C 636.2511 II 702.822 0 III 637.282 Ar III 702.899 0 III ΙI 641.888 C 703.850 C III II 0 644.148 704.5233 Ar II 644.634 N ΙI Ar V 709.195 II 644.837 N 713.518 N V ΙI 645.178 N N V 713.860 C 651.211 II716.55 0 V 0 651.234 II Ar II 718.0903 651.269 II ΙI 0 718.484 C 651.304 ΙI 718.562 0 ΙI C Ar II 651.345 II 723.3611 C 651.389 ΙI 725.5481 Ar II N 657.327 ΙI 728.74 0 V 658.578 0 III 730.9293 Ar II 659.538 0 II, N II Û ΙI 739.949 660.286 N ΙI 740.2695 Ar II 661.8692 Ar ΙI Ar II 744.9252 Ar 664.5626 ΙI 745.841 N ΙI 666.0112 Ar II 746.984 IIN 670.296 II V ? N 748.291 Ν 670.515 II N Ι 748.4 0 671.016 ΙI 749.3 N 0 Ι 671.411 N ΙI 752.762 0 III 671.773 N ΙI Ū 756.7 Ι 672.001 ΙI N 759.440 0 V 672.948 0 ΙI V 760.445 G

Identification Identification Wavelength (A) (A) Wavelength 763.340 836.279 N III N ΙI 764.357 836.289 N III N II 765.148 N IV 836.616 N ΙI 769.152 Ar III 836.627 N II 769.355 0 Ī 836.837 N II 769.411 Ι 0 2×418.705 III N 770.264 0 I 2×418.910 N III 770.350 0 Ī 843.772 Ar IV 771.544 III N 850.602 Ar IV 771.901 N III C ΙI 858.0918 772.385 858.5590 C II N III 772.891 III 866.805 Ar Ι N 772.975 III 871.099 Ar III N 774.522 0 V 884.516 C III 775.965 ΙI 888.019 N I N 2×389 888.363 C III ? N I 778.172 Ν V 894.310 Ar Ι 783.14 898.957 0 III Ar 784.393 901.168 Ar ΙV C III 787.710 0 901.804 Ar IV IV 790.103 C 903.6235 II 0 IV 790.203 903.9616 C 0 IV II 791.974 0 Ι 904.1416 C II 792.233 C 904.4801 II 0 I 792.507 Ι G İ 905.829 N 906.722 I 795.134 C II N 796.661 Ι 0 906.824 N ΙI 799.660 C N Ι ? 909.6976 II 1 ? 799.944 C 910.2785 II Ν I ? 802.198 0 IV 910.6456 Ν 802.250 0 N II IV 915.612 C 806.384 II II 915.962 N C 803.533 916.012 N II II 806.568 C II 916.020 N II 806.830 C N II II 916.701 806.860 C ΙI II 916.710 Ν 809.677 C Ar ΙI II 919.7815 811.052 0 Ι 921.992 N IV ? 822.161 V ? 922.519 N IV ? Ar 827.052 IV? V ? N Ar 923.057 832,762 923.220 N IV ? 0 II 832.927 IV ? 0 923.675 Ν III 833.332 924.283 IV 0 N II 833.742 0 953.9698 N Ι II 834.462 Ι 954.1040 N 0 II 835.096 0 III 955.335 Ν IV 835.292 II 958.670 H. 0 III 836.187 II 958.724 He N ΙI

Identification Wavelength (A) Identification Wavelength (A) I 1097.245 963.9904 N N I I 964.6258 N 1098.264 N Ι I 965.0415 N 1100.3593 Ι N Ι 1101.2910 971.7376 0 I N 1122.328 ΙI 972.138 He C Ι 0 Ι 1134.1651 973.2346 N Ι 0 Ι 1134.4147 973.8857 I N 976.4480 u Ι 1134.9801 N I C III 977.020 1135.244 IV N III 1141.6246 979.842 N C II N III 1143.606 979.919 I N N 989.790 III 1143.6508 Ι N 991.514 N III 1149.603 III 0 1152.152 991.579 N III Ι 0 1156.028 992.334 He II C I ΙI 1156.560 992.391 He C I 0 I 1163.8835 999.493 N I 1006.015 N III 1164.2064 Ι N N I 1164.3246 1008.875 I N C ΙI 1167.4484 1009.862 Ī N C II 1168.3344 1010.092 N I C ΙI 1168.5358 1010.374 N I He ΙI 1169.6933 1025.241 Ĭ N 1025.302 He ΙI 1170.2766 N Ι 1171.0834 1025.7616 U Ι N Ι I 0 1170.2766 1027.4309 Ι N 0 Ι 1174.933 1028.1571 C III Si III ? 1175.711 1031.169 C III I 1032.958 N 1176.370 C III Ι 1933.453 N 1176.5097 N Ι C 1177.6948 1036.3367 ΙI Ι N C ΙI 1183.030 1037.0182 N III 1184.544 N Ι 1044.094 N III Ι 1188.006 1044.724 N N IV C 1065.8913 II 1193.240 C I C 1065.9199 ΙI 1196.1 Si N Ι 0 II 1199.5490 1066.1332 Ι N I 1200.2238 V. 1066.641 1067.399 N Ι 1200.7113 N Ι 1068.476 Ι 1215.171 H. II N Ι Н Ι 1069.984 Ν 1215.668 IV Н Ι 1078.708 N 1215.674 1225.192 1083.990 N II N IV II N N IV 1084.582 1225.719 1084.908 He ΙI 1228.790 N I C II IV 1084.975 He 1230.511 1085.701 N! ΙI 1238.821 N V

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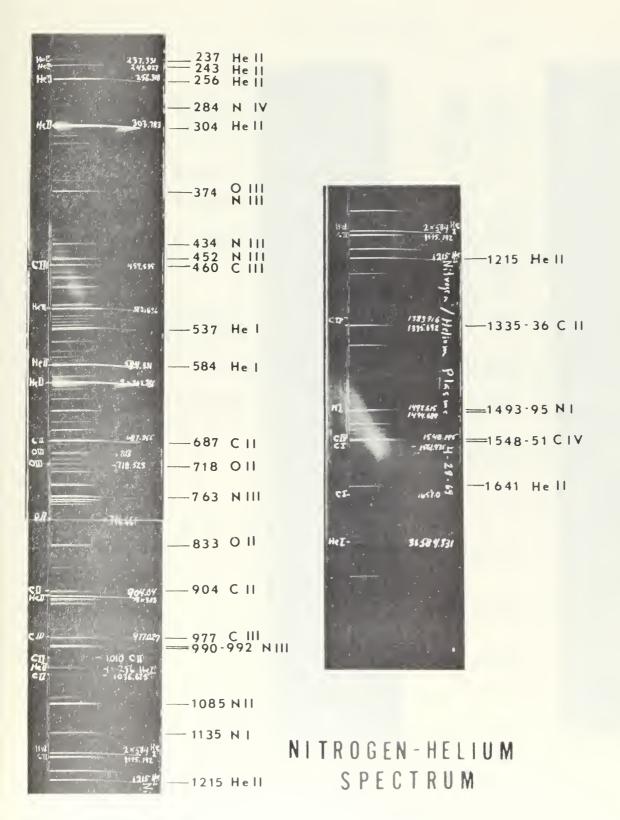


FIG. 12

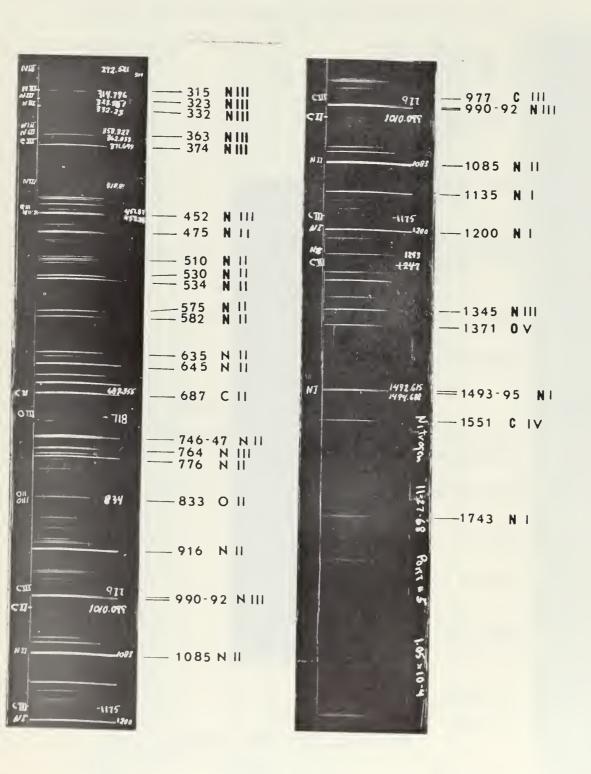
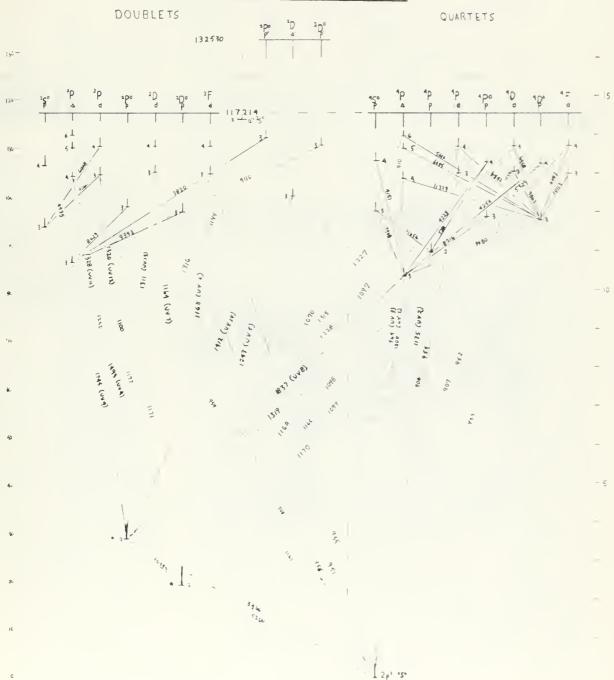


FIG. 13
NITROGEN SPECTRUM

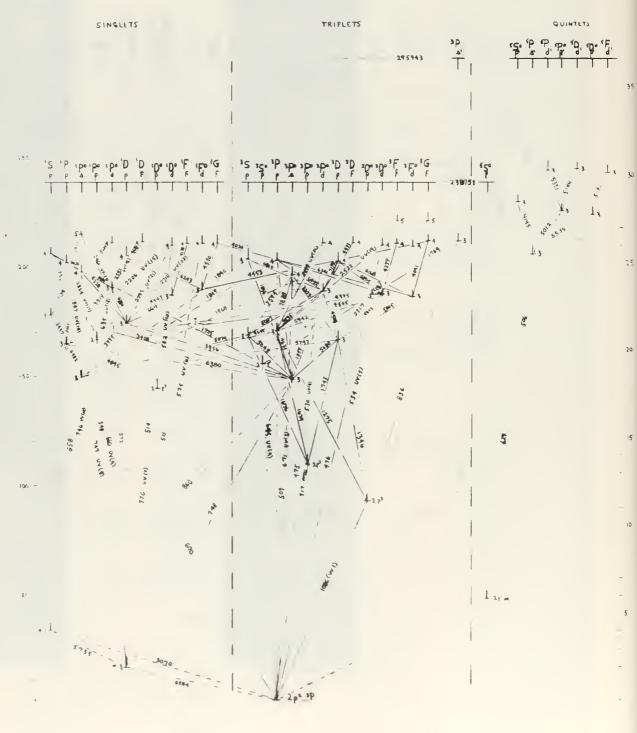
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APPENDIX E - GROTRIAN DIAGRAMS

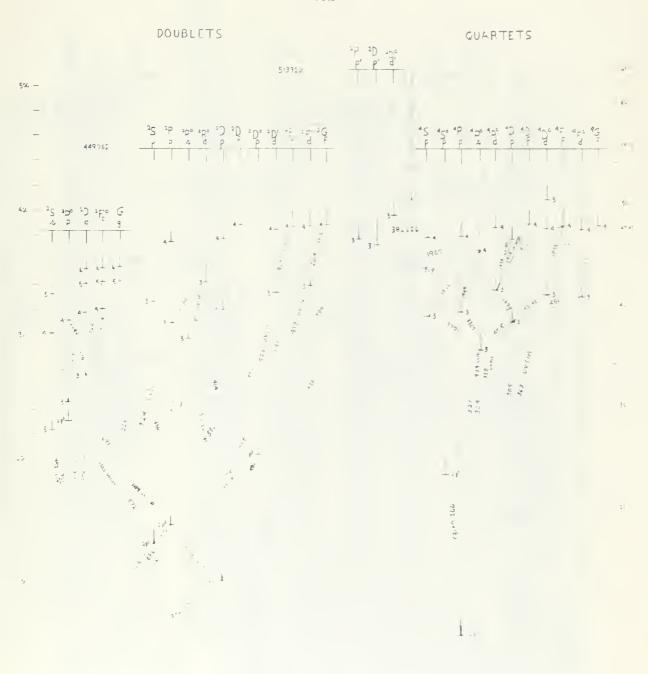


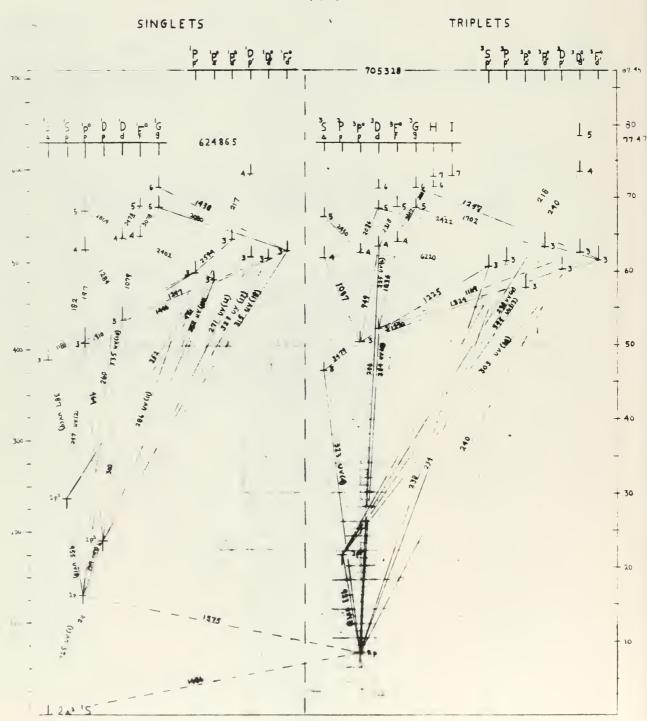
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62 FELATIVELY FOUR RESPONSE.

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64 FART GARGE SET (MICHI) / GAMMA

65 FATTO GARGE SET (MICHI) / GARGE SET (MICHI)
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CATA +4621.405E-10 +4613.887E-10 +46643.106E-10 +4661.490E-10 +4124.100E-10 +4133.654E-10 0000000 PHOTOMETR. 106 0758 07796 1133 1118 CSIGB CAVE=AVE+SIGB CAVE=AVE-SIGB WRITE(6,211) PAVE, OAVE FERR=SIGB*100.0/AVE WRITE(6,212) PERR CAVE = CAVE + CSIGB CAVE = CAVE + CSIGB CAVE = CAVE + CSIGB WRITE(6,211) PAVE, OAVE FERR = CSIGB*100.0/CAVE GO TO 20 STOP u.iu.i w 0000000 NNNN LC34334034300W 2211.06 2211.006 2211.0062 228.36 10.362 00

HAVE THE STATE OF	SAMPLE ELECTRON TEMPERATURE OUTPUT		ETECTRON TE	FLECTRON TEMPERATURES	INTENSITY RATIF
THE FOLLOWING LINES	ARE PASED ON THE WAVELENGTH OF 4621,405E-10				
4613.887E-10	PEJECTED: EXCIPC DIFFERENCE TOO SMALL	0.001			
4607.166E-10	PEJECTEO: EXCIPC OIFFERENCE TOO SMALL	0.002			
4543.106E-10	REJECTED: FXCIPO DIFFERENCE TOO SMALL	0.004			
46C1.490E-10	REJECTED: EXCIPG OIFFERENCE TOO SMALL	0.010			
4124.100E-10	REJECTED: INTENSITY RATIC TOO LARGE	4.040			
4133.654E-10			3.8545	7.2920	2.5637
4145.759E-10			3.5106	6.1520	2.2246
THE FOLLOWING LINES ARE PASED	ARE PASED ON THE MAVELENGTH OF 4613.887E-10				
4607.166E-10	REJECTED: EXCIPO DIFFERENCE TOO SMALL	0.001			
4643.106E-10	REJECTED: EXCIPO DIFFERENCE TOO SMALL	0.003			
4601.49CE-10	REJECTED: EXCIPO DIFFERENCE TOO SMALL	60000			
4124.100E-10			4.1920	R.5021	2.754R
4133.654E-10			4.0776	8.1340	1.7481
4145.759E-10			3.6947	6.7404	1.5169
THE FOLLOWING LINES ARE BASED	ARE BASED ON THE WAVELENGTH OF 4607.166E-10				
4643.106E-10	REJECTED: EXCIPG DIFFERENCE TOO SMALL	0.002			
4601.490E-10	PEJECTED: EXCIPO DIFFERENCE TOO SMALL	0.008			
4124.100F-10			4.0717	8.1102	3.8927
4133.654E-10			3.9637	7.6928	2.4702
4145.759E-10			3.6009	6.4345	2.1434
THE FOLLOWING LINES	THE FOLLOWING LINES ARE BASED ON THE WAVELENGTH OF 4643.106E-10				
4601.490E-10	PEJECTED: EXCIPO DIFFERENCE TOO SMALL	90000			
4124.1CCE-10	PEJECTEN:WAVELENGTH DIFFERENCE TOO LARGE 519.	519.006E-10			
4133.654F-10	FEJECTED: MAVELENGTH DIFFERENCE TOO LARGE 509.	509.452E-10			
4145.759E-10			3.2298	5.3382	3.2856
THE FOLLOWING LINES	THE FOLLOWING LINES ARE BASED ON THE WAVELENGTH OF 4601-490E-10				
4124.100E-10	REJECTED: INTENSITY RATIO TOO LARGE	4.258			
4133.654E-10			4.2718	8.9431	2.7010
4145.759E-10			3.8530	7.2849	2.3445
THE FOLLOWING LINES ARE BASED	ARE BASED ON THE MAVELENGTH OF 4124-100E-10				
4133.654E-10	PEJECTED: FXC1PC DIFFERENCE TOO SMALL	0.001			
4145.759E-10	PEJECTED: EXCIPO DIFFERENCE TON SMALL	0.002			
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4145.759E-10	REJECTED: EXCIPO NIFFERENCE TOT SMALL	0.001			

MAXIMUM MAVELENGTH DIFFERENCE = 500.0F-10 METERS

MINIMUM EXCITATION POTENTIAL DIFFERENCE = 4.0 VOLTS

MAXIMUM ALLOWABLE INTENSITY RATIO = 4.0

MINIMUM ALLOMABLE INTENSITY RATIO = 0.25

E- TEMPERATURE = 3.0473 +/- 0.0907 ELECTRON VOLTS LTE MODEL

TEMPERATURE RANGE: 3.9380 TO 3.7566

PERCENT ERADR = 2.36 PERCENT

E- TERPERATURE = 7.3385 +/- 0.3164 ELECTRON VOLTS CORONA HODEL

TEMPERATURE RANGE: 7-4550 TO 7-0221

PERCENT ERROR = 4.31 PERCENT

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THIS PROGRAW IS DESIGNED TO CALCULATE RELATIVE

CARELTATION POTENTIALS.

CARELTATION POTENTIALS.

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I, WL(I), EXCIPD(I), JUPPER(I), JLOW(I), F(I), LOCINT(I)
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COMPUTER PROGRAM GLOSSARY

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= AVERAGE ELECTRON TEMPERATURE (EV)
= CORONA MODEL INTENSITY
= EXCITATION ENERGY DIFFERENCE
= EXCITATION ENERGY OF SPECTRAL LINE
= ABSORPTION OSCILLATOR STRENGTH
= SLOPE OF LOG RELATIVE DENSITY VS LOG EXPOSURE
= STATISTICAL WEIGHT OF LOWER STATE OF SPECTRAL L
= ELECTRON TEMPERATURE SET FOR RELATIVE INTENSITY
AVE
CORINT
                    =
CRIT
                    =
GAMMA
GLOW
I TEMP
                                                                                                                                                                     LINE
                           PROGRAM
                           SPIN-ORBITAL ANGULAR MOMENTUM QUANTUM NUMBER OF LOWER STATE
JLOW
                           SPIN-ORPITAL ANGULAR MOMENTUM QUANTUM NUMBER OF UPPER STATE
JUPPER
                          LOCAL THERMAL EQUILIBRIUM RELATIVE INTENSITY
LOCAL THERMAL EQUILIBRIUM
LINEAR COMBINATION OF LTE AND CORONA MODEL
RELATIVE INTENSITIES
AVERAGE ELECTRON TEMPERATURE + STANDARD DEVIATION
OF THE MEAN
LOCINT
MIX
PAVE
                           ISTANDARD DEVIATION OF THE MEAN / AVERAGE ELECTRON
PERR
                          (STANDARD DEVIATION OF THE MEAN / AVERAGE ELECTRON TEMPERATURE) * 100.0

AVERAGE ELECTRON TEMPERATURE - STANDARD DEVIATION OF THE MEAN RELATIVE INTENSITY RATIO MAXIMUM INTENSITY RATIO MINIMUM INTENSITY RATIO PELATIVE INTENSITY (OR DENSITY) OF SPECTRAL LINE BASE RELATIVE INTENSITY FOR ELECTRON TEMPERATURE CALCULATIONS

STANDARD DEVIATION OF THE MEAN STANDARD DEVIATION
DAVE
RATIO
RATMAX
RATMIN
                     =
RELINT
                     =
SIGB
                     =
                          STANDARD DEVIATION
STANDARD DEVIATION
LTE MODEL ELECTRON TEMPERATURE (EV)
CORONA MODEL ELECTRON TEMPERATURE (EV)
MINIMUM EXCITATION ENERGY DIFFERENCE
MAXIMUM WAVELENGTH DIFFERENCE
WAVELENGTH DIFFERENCE
WAVELENGTH
SIGM
                     =
THP
                     =
VE
                     =
VWL
                     =
WAVE
                     =
WL
                          TERMS USED IN COMPUTING AVERAGE VALUES AND EVIATIONS MAY BE MODIFIED BY PREFIX "C" INDICATE CORONA MODEL CALCULATIONS
NOTF:
                                                                                                                                                AND
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BIBLIOGRAPHY

- 1. Andrews, R. C., Shock Production, Langmuir Probe Diagnostics, and Instabilities in a Nitrogen Plasma, Master's Thesis, Naval Postgraduate School, Monterey, California, 1968.
- 2. Orlicki, G. A., Spectroscopic Diagnostics of a Nitrogen Plasma, Master's Thesis, Naval Postgraduate School, Monterey, California, 1968.
- 3. Kaufman, L. E., <u>Investigations in the Vacuum Ultraviolet Using</u>
 <u>a Grazing Incidence Spectrograph</u>, <u>Master's Thesis</u>, <u>Naval</u>
 Postgraduate School, <u>Monterey</u>, <u>California</u>, 1967.
- 4. Samson, J. A. R., <u>Techniques of Vacuum Ultraviolet Spectroscopy</u>, p. 34-40, Wiley, 1967.
- 5. Beutler, H. G., "The Theory of the Concave Grating," J. Optical Society of America, v. 35, p. 311ff, May, 1945.
- 6. Samson, J. A. R., op cit, p. 11-14.
- 7. Orlicki, G. A., op cit.
- 8. Rose, D. J., and Clark, M. Jr., Plasmas and Controlled Fusion, p. 165-172, MIT Press and Wiley, 1961.
- 9. Huddlestone, R. H., and Leonard, S. L., (ed), <u>Plasma Diagnostic Techniques</u>, R. W. P. McWhirter, "Spectral Intensities," p. 201-261, Academic Press, 1965.
- 10. Griem, H. R., Plasma Spectroscopy, p. 129-167, 267-278, 425-431, McGraw-Hill, 1964.
- 11. Robinson, D. and Lenn, P. D., "Plasma Diagnostics by Spectroscopic Methods," Applied Optics, v. 6, No. 6, p. 983-1000, June 1967.
- 12. Wiese, W. L., Smith, M. W., and Glennon, B. M., Atomic Transition Probabilities, v. 1, Hydrogen through Neon, NSRDS-NBS4, Government Printing Office, May 20, 1966.
- 13. Kelly, R. L., A Grazing Incidence Vacuum Spectrograph of Simple Design, Stanford Research Institute, December 31, 1959.
- 14. Kaufman, L. E., op cit.
- 15. Harrison, G. R., Lord, R. S., and Loofbourow, J. R., Practical Spectroscopy, p. 356, Prentice-Hall, 1948.
- 16. Eastman Kodak Company, Kodak Plates and Films for Science and Industry.

- 17. Moore, C. E., Atomic Energy Levels, Vol. I, p. 32-42, NBS 467, Government Printing Office, June 15, 1949.
- 18. Moore, C. E., An Ultraviolet Multiplet Table, NBS 488, Section 4, Government Printing Office, April 6, 1962.
- 19. Kelly, R. L., Atomic Emission Lines Below 2000 Angstroms, Hydrogen through Argon, Naval Research Laboratory 6648, February, 1968.
- 20. Samson, J. A. R., op cit, p. 43-83.
- 21. Keller, L. R., Ultraviolet Radiation, 2d ed., Wiley, 1965.

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13. ABSTRACT

In preparation for studies of shock waves in a collisionless plasma, a grazing incidence vacuum spectrograph has been used to study the vacuum ultraviolet spectra of a nitrogen plasma. The spectra are formed by a concave grating with a 1-meter radius of curvature and recorded on Kodak SWR (Shortwave-Radiation) Film. Analysis of the spectra was by comparison with helium and argon spectra, with intensity information from densitometric measurement using a Leeds and Northrup recording densitometer. Relative intensity determination provides an electron temperature evaluation technique.

Details on the modification of the Naval Postgraduate School plasma facility to accommodate a theta-pinch shock generation experiment are presented. Revised operating procedures for the new system configuration are included in the appendix.

A total of 735 lines was observed in the range 300-2000 angstroms. Relative intensity measurements indicated electron temperatures in the range 7.3 to 19.7 electron volts. Predicted relative intensities using a variable combination of the Local Thermal Equilibrium and Corona plasma models showed good sensitivity to temperature, but little difference between models.

Unclassified - Security Classification			LINK A		LINK B		LINK C	
	KEY WORDS		ROLE	WT	ROLE	WΤ	ROLE	WI
plasma spectr	coscopy							
ultraviolet								
nitrogen								
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